

Experimental Study of the Impact of Substrate Shape and Tilting on Particle Velocity in Suspension Plasma Spraying

Alice Dolmaire, Simon Goutier, Aurélien Joulia, Pierre-Marie Geffroy, Michel Vardelle, Luc Bianchi

▶ To cite this version:

Alice Dolmaire, Simon Goutier, Aurélien Joulia, Pierre-Marie Geffroy, Michel Vardelle, et al.. Experimental Study of the Impact of Substrate Shape and Tilting on Particle Velocity in Suspension Plasma Spraying. Journal of Thermal Spray Technology, 2020. hal-02453433

HAL Id: hal-02453433 https://unilim.hal.science/hal-02453433v1

Submitted on 11 Dec 2020

HAL is a multi-disciplinary open access archive for the deposit and dissemination of scientific research documents, whether they are published or not. The documents may come from teaching and research institutions in France or abroad, or from public or private research centers.

L'archive ouverte pluridisciplinaire **HAL**, est destinée au dépôt et à la diffusion de documents scientifiques de niveau recherche, publiés ou non, émanant des établissements d'enseignement et de recherche français ou étrangers, des laboratoires publics ou privés.

Experimental study of the impact of substrate shape and tilting on particle velocity in

Suspension Plasma Spraying

- 3 A.DOLMAIRE^{1,2}, S.GOUTIER¹, A.JOULIA², P-M.GEFFROY¹, M.VARDELLE¹,
- 4 L.BIANCHI³
- ¹Univ. Limoges, CNRS, IRCER, UMR 7315, F-87000 Limoges, France
- ²Safran Tech, Rue des Jeunes Bois, 78772 Magny Les Hameaux, France
- ³Safran Aircraft Engines, 1 Rue Maryse Bastié, 86100 Châtellerault

9 Abstract

Suspension plasma spraying has shown its capacity to deposit finely structured coatings with a wide range of microstructures including columnar microstructures that are generally sought in thermal barrier coating applications for gas turbines. However, some challenges are still to be taken up before the application of the technology at an industrial scale. One deals with the deposition of a uniform and reliable coating on a complex shape substrate. This work offers an experimental observation of submicron particle streams close to the substrate in order to understand mechanisms of deposition. Effects of the substrate shape and tilting were investigated on particle velocity, directions and coating growth. It was shown that particle velocities and directions are disrupted by the substrate presence up to 10mm upstream. When the substrate is a cylinder or in a tilted orientation to the plasma jet, particles kinetic behaviour is less affected. Finally, submicron particle velocity vectors orientation near impact greatly shape the coating morphology. When impacting with a 40° angle of incidence, columns appeared on beads, contrary to submicron particle streams impacting orthogonally to the substrate surface.

- 1 Keywords particle velocity, suspension plasma spraying, thermal barrier coating, columnar
- 2 coating, substrate shape, substrate orientation, PIV

Introduction

Suspension Plasma Spraying (SPS) is now emerging at the industrial scale, with most activities affecting new processes on the improvement of coatings on gas turbines. In this context, coatings need to be homogeneously deposited along the surface of turbine blades to be truly effective. However, turbine blades are made of complex forms with a variety of thicknesses, curves and type of edges, which greatly influence the morphology and quality of the coatings obtained by SPS [1]. To improve deposition rate and quality, further investigations are needed to understand the behaviour of submicron particles flow in the plasma jet impinging the surface of substrates.

In Atmospheric Plasma Spraying (APS), particles launched at high speed have trajectories quasi parallel to the gun axis and almost all resulting impacts on the substrate are orthogonal to the target surface [2,3]. The kinematic treatment depends a lot on particle mean size $d_{\scriptscriptstyle D}$ which is in this case about more than $10\mu m$ [2,4,5].

However, in Suspension Plasma Spraying (SPS), submicron and nano-sized particle trajectories are greatly affected by flow fluctuations [6] and any velocity gradients [5,7]. Especially, near the target, these particles are very sensitive to the plasma flow directional change induced by the stagnation region [8], seemingly following plasma flow streamlines due to their very low Stokes number [9–12].

Moreover Pourang et al. [13], have numerically simulated the trajectory of a suspension of zirconia droplets within a plasma jet near a flat or curved surface. Their simulation has shown a significant influence of the substrate shape on particle trajectories in the vicinity of the substrate surface. Particles within a plasma jet impinging a cylindrical substrate were twice as likely not to deposit on the substrate surface. When impacting the cylinder, these particles also had a lower normal velocity (as regards the substrate normal axis) than particles impinging a flat substrate due to a narrower stagnation area.

Finally several models on coating growth in SPS have been suggested from experimental observations of coating morphologies obtained with varying sets of process parameters [14–18]. These models all agree on the great influence of particle direction and velocity when impacting the substrate on the resulting coating morphology. More precisely, the impacting directions of these particles on a peak of roughness seem to shape the coating into columnar morphologies via the shadowing effect.

Thus the presence of an obstacle totally disrupts the plasma and particle flow streams and affects their respective average velocity [19]. If submicron particles precisely follow plasma flow streamlines, as shown in simulations, how then is a SPS coating built when the centerline of the particle flow bearing a maximum of particles concentration rapidly decelerates and is easily deviated by the stagnation area?

No experimental investigation has yet been published, to the authors' knowledge, on the kinetic behaviour of suspension submicron particles in plasma jets impinging substrates. The objective of this study is therefore to provide it. Particle Image Velocimetry (PIV) will be used in order to observe submicron particles kinetic behaviour near two types of substrates, a flat substrate or a cylindrical one, with a tilted orientation or not to the plasma flow axis. Next the resulting coating morphologies will be analysed thanks to observations of cross-sections.

Experimental methods and set-up

Particle Image Velocimetry (PIV) principle and set-up

PIV measurements consist in capturing movements of particles in a fluid thanks to an advanced optical set-up combined with a digital image correlation technique.

In this system (Fig. 1), two high-speed cameras were orthogonally placed to each other. The light is collected by the two cameras thanks to a beam-splitter. The lens of the first camera also determined the field of interest, i.e the spatial resolution. In this study the field was $12x8mm^2$ and was 1mm deep. A double-pulsed Nd:YAG laser (wavelength λ =532nm) was used to radiate particles travelling through this field. The two cameras were then respectively synchronised to be exposed to only one pulse of the laser at a time in order to detect any movement in a couple of frames.

For this study, 100 image couples of dimensions 12x8mm² and of exposure time 1µs were taken per operating condition. These conditions consisted in varying the substrate shape in front of the plasma jet as well as the tilting of the plasma gun in front of a flat substrate. The plasma gun working conditions were set constant during these sprayings. They are described in the next paragraph. Velocity fields were calculated from these 100 couples via an Eulerian approach thanks to the PIV software DaVis 8 (LaVision, Göttingen, Germany). Spatial auto-correlation was used to calculate the average pixel displacement of clouds of zirconia particles in an interrogation area of 128x128pixels within a partial window of dimensions 3x3mm². An overlap of 50% was applied between each interrogation area. These correlation parameters allows to obtain up to 9000 velocity vectors for 100 velocity fields of dimensions 3x3mm². Arithmetic averages of magnitudes of these velocity vectors were then

- 1 extracted from each windows of 3x3mm². An average measurement error of 30m·s⁻¹ on
- 2 particle average velocity was estimated from the slight variations of substrates positioning
- 3 between and during spraying.

5

- Spraying conditions and beads production
- 6 The ethanol-based suspension was homemade using an 8wt.% yttria stabilized zirconia
- submicron powder ($d_{50,v} = 0.7 \mu m$) from IMERYS Fused Minerals (Laufenburg, Germany)
- 8 and 2wt.% of phosphate ester as the dispersing agent (3DCeram, Limoges, France).
- 9 A TriplexPro-200 plasma gun from Oerlikon-Metco (Kelsterbach, Germany) was used
- to conduct the study. Spraying conditions are detailed in Table 1.
- The suspension was then inserted in a pressurized tank with a magnetic agitation put
- underneath. It was later injected radially to the plasma jet at 4mm from the nozzle exit. The
- injector diameter was 150µm and the suspension flowrate around 30mL·min⁻¹.
- Two types of substrate were positioned at a standoff distance of 60mm (Fig. 2):
- A water-cooled circular copper plate, of diameter 50mm and thickness 28mm, put normal
- to the plasma flow in order to simulate a flat substrate (disk). It had a frontal area of
- 17 1964mm².
- Stainless steel rings, of diameter 50mm, height 32mm and thickness 2mm, set vertically
- to behave as cylindrical substrates with a curvature radius of 25mm and a frontal area of
- 20 1600mm².
- In order to cool down substrate surfaces during each spray, standard TriplexPro
- commercial air-jets were used (details in Tab. 1). During PIV measurements, the cooled

copper plate was set immobile while stainless steel rings were mounted vertically on a chuck rotating at 100rpm (Fig. 3).

Part of the study is dedicated to apprehending the influence of the substrate orientation on the submicron particle flow behaviour. Due to the limitations of the PIV set-up, it was of best interest to orient the plasma jet with respect to the normal axis of the substrate instead. Indeed, this configuration allowed to recreate a plasma flow impinging an inclined surface as well as to maintain the same measuring volume. Two orientations of plasma jet were chosen: parallel to the normal axis of the substrate (0° of incidence) or impinging with a 40° angle of incidence.

Next, this effect of the substrate orientation was studied by examining beads cross-sections. These beads were sprayed on grit-blasted stainless steel rings while maintaining the plasma gun motionless. Their cross-section were observed thanks to a JEOL IT300LV (Jeol Europe, Croissy sur Seine, France) scanning electron microscope in order to characterize the plasma jet position effect on the obtained coating morphology. Porosity in the beads was also evaluated from the micrographs by image analysis using the open-source software ImageJ.

Estimated plasma jet thermophysical properties in the vicinity of substrates

In order to interpret velocity results, thermophysical properties of the plasma jet were necessary for an 80%-20% argon-helium gas mixture with atmospheric air surrounding it at x=60mm. Thus, the temperature, the viscosity and the density of the plasma flow were broadly estimated at x=60mm as follow.

The plasma temperature T_{plasma} was first estimated by measuring the melting point position $T_{alumina}$ of an alumina rod of diameter 3mm in the plasma flow. The tip of the rod started to melt at x=55.5mm from the nozzle exit. Using previous work [20], values of the

1 heat transfer coefficient h were considered to vary between 1500 and 3000W·m⁻²·K⁻¹ and

thermal flux density Φ values in a range of 2 to 3MW·m⁻² at x=60mm from the gun nozzle

3 exit. Thermal gradient in the boundary layer of the plasma flow could then be evaluated

4 thanks to the following equation (Eq. 1).

$$\Phi = h \left(T_{\text{plasma}} - T_{\text{alumina}} \right) \quad \text{(Eq. 1)}$$

Therefore, the plasma temperature T_{plasma} around 60mm had been approximated to be roughly between 5150 and 5850K. In order to simplify further calculations, plasma temperature was set on the average value, which was 5500K. This value is close to previous SPS models with similar plasma conditions [11,13]. Thanks to this plasma temperature estimation, it was then possible to infer viscosity and density values for an argon-helium-air mixture at x=60mm. Volume fraction of air was set at 90% at this distance from the nozzle exit in the gas mixture [21]. Taking into account such air entrainment, plasma viscosity μ_g was estimated to be around $1.6\cdot10^{-4} \text{kg·m}^{-1}\cdot\text{s}^{-1}$ and density ρ_g around $5.4\cdot10^{-2} \text{kg·m}^{-3}$. These calculated properties will be taken into account for the following estimations.

Fluid dynamic of the plasma and particle flow in the vicinity of substrates

Reynolds number of the plasma jet and drag forces applied on the substrates can be estimated at x=60mm thanks to the calculations in the previous paragraph. Submicron particles timely response to the plasma jet can also be gauged thanks to the Stokes number. These numbers and forces will help to better understand the dynamic behaviour of both flows (plasma and submicron particles) and thus will help into the interpretation of results on particle velocity.

Definitions of Reynolds number Re, drag force F_{d} and Stokes number St are described subsequently.

1 Re =
$$\frac{\rho_g \ v_g \ d_s}{\mu_g}$$
 (Eq. 2)

$$F_{d} = \frac{1}{2} \rho_{g} v_{g}^{2} A C_{d} \quad (Eq. 3)$$

St =
$$\frac{1}{18} \frac{\rho_p d_p^2 v_g}{\mu_g D}$$
 (Eq. 4)

In the expression of the Reynolds number (Eq. 2), symbols ρ_g , v_g , and μ_g represent in this order density, velocity and viscosity of the mixture argon-helium-air at x=60mm. As zirconia particles suspended in the plasma jet in this study have a median diameter of 0.7 μ m, particle velocity is assumed to be equal to plasma velocity around x=60mm [5,11,13]. The average particle velocity value in a free jet at the centerline will be taken in this case. Symbol d_s in this expression corresponds to the diameter of both substrates which is 50mm.

Symbol A in the third equation represents the frontal area of the substrate, of value 1964mm^2 for the flat substrate or 1600mm^2 for the cylindrical substrate. C_d is the drag coefficient of the substrates, depending on the Reynolds number of the plasma and air mixture.

In the Stokes number definition (Eq. 4), ρ_p and d_p are respectively density and mean diameter of the submicron zirconia particles, with respective values of $5890 \text{kg} \cdot \text{m}^{-3}$ and $0.7 \mu \text{m}$.

Then in a similar fashion than Anderson and Longmire [22], two Stokes numbers will be computed, St_0 corresponding to the particle-fluid relation at the nozzle exit of the plasma gun ($St_0 = \rho_p d_p^2 v_{g0}/18 \, \mu_{g0} D_0$) and St_{60} corresponding to the particle-fluid relation far downstream, around 60mm ($St_{60} = \rho_p d_p^2 v_g/18 \, \mu_g D_0$). In the first case, the plasma velocity at nozzle exit v_{g0} , the diameter of the nozzle D_0 and the viscosity of the plasma mixture at nozzle exit μ_{g0} are taken into account (values in Tab. 1).

Results and discussions

The aim of these measurements is to visualize the particle flow in the vicinity of the substrate surface and estimate the average value of the magnitude of particle velocity both axially, along the centerline of the plasma jet, and radially, along the plasma jet radius.

Axial evolution of particle velocity at the center of the plasma jet, comparisons between free

jets and impinging jets at x=60mm from the nozzle exit

First, it is worth noting that the use of commercial cooling air-jets surrounding the gun nozzle had an impact on the plasma flow behaviour in front of the substrates. Indeed working with such cooling air flow macroscopically created an air barrier before the surface of the substrates compared to a spray with no air-jets in the same operating conditions (Fig. 4). This cold barrier had a thickness around 3mm according to the corresponding velocity fields. Despite these observations, cooling air-jets were maintained to a minimum value, for every tested operating condition in order to minimise experimental variables and optimise the survival of substrates during and after each spray.

Effect of the presence of a wall on the axial evolution of particle velocity

Average particle velocities were measured at the center of the plasma jet (y=0mm) between x=50mm and 60mm from nozzle exit. As reported in Fig. 5, velocity measurements of suspensions in a free jet showed a natural deceleration of 70m·s^{-1} in 10mm, from x=50mm to 60mm. On the other hand, free jet with surrounding air-jets showed a deceleration of about 100m·s^{-1} on a distance of 6mm from x=50.5mm to 56.5mm. Additionally, these particles

travel faster than the particle jet impinging a surface positioned at x=60mm. Indeed, a

2 maximum gap of 200m·s⁻¹ at 53.5mm from nozzle exit was registered between particles

dragged in a free jet compared to particles encapsulated in a plasma jet impinging a flat

4 substrate, with cooling air-jets in use in both cases.

5 Stokes numbers were computed for the submicron particle flow along the axis of the

plasma jet and evolve from 0.16 (St₀) to 0.06 (St₆₀). In all cases, Stokes numbers are below 1.

This means zirconia submicron particles are very sensitive to the plasma jet behaviour and

strictly follow the plasma jet streamlines even with a decreasing plasma viscosity.

All of the above indicates the presence of a wall in front of the plasma jet disrupts greatly its dynamic behaviour which results in braking the suspension particle flow significantly upstream within the plasma jet. This braking effect is also an indirect indication of the existence of a stagnation area for the plasma flow created by the presence of a substrate. A stagnation area is a definite space where fluid particles are brought to rest due to a particular geometry of an obstacle met by the plasma flow. The dimensions of this flat substrate suffice in creating such an area.

Moreover the addition of said cooling jets has a negative effect on particle velocity. When comparing both particle flows impinging a flat substrate (Fig. 5), average velocity values drop off between 100m·s⁻¹ and 150m·s⁻¹ at respectively 50.5mm and 53.5mm from nozzle exit. Naturally this loss of speed depends a lot on air nozzle orientation and air flow rates. In many industrial cases implementing a rotating substrates carrier, it is then beneficial to turn off standard air-jets fixed on the gun, and cool down the substrates using others systems.

Thus, when spraying on a surface the average magnitude of particle velocity is affected by a double negative effect: the use of cooling air-jets surrounding the plasma jet and

- the presence of the surface itself which disrupts and brakes the particle flow upstream, in this
- 2 case up to 10mm upstream.

Effect of the shape of the substrate on the axial evolution of particle velocity

As shown in Figure 6, the average particle velocity values did not change significantly in front of the cylindrical or flat substrate geometries used in this work. Moreover, particle velocities at the center of the plasma jet decrease at the same rate in both cases. This lack of a significant difference may be the result of the small and similar cross sectional shapes of the geometries chosen. Indeed, Reynolds number of the plasma flow in front of these substrates is identical (diameter is identical for both substrates) and of magnitude 5.10³.

However, drag coefficients for these substrates at this value of Reynolds number depend on their aspect ratio according to Hoerner's experimental diagrams [23]. For the flat substrate, it is a disk of aspect ratio length/diameter of 0.56, therefore a drag coefficient C_d of 1.02 according to Hoerner. In the case of the cylindrical substrate the aspect ratio diameter/length was of 1.56 which corresponds to a drag coefficient C_d tending to 0.70. Drag forces of these substrates are then respectively of 4.9N for the flat substrate and 2.7N for the cylindrical substrate. Therefore, the cylindrical substrate should show slightly less resistance to the plasma flow.

The braking effect on the particle velocity produced by the substrate appears on Fig. 6 to extend less strongly upstream with a cylindrical surface than with a flat substrate, higher average velocities being registered in this former case. This trend is due to the curvature radius (25mm) of the cylinder which impacts the drag force on the plasma jet and is coherent to the drag force calculation which is lower for the curved substrate. Increasing the length or reducing the curvature radius of the cylinder would likely exacerbate any differences in the

1 particle flow kinetic behaviour in the vicinity of these two types of substrate. Moreover, the

2 curvature radius of the cylinder implies that plasma jet streamlines along the z axis are less

and less subjected to an obstacle orthogonal to their trajectories. Therefore, with this curved

target the stagnation zone is also weakened in size and submicron particles are less

decelerated by this change of plasma flow behaviour. This trend on velocity results in front of

a curved substrate is in agreement with simulations [13, 19].

7

8

3

4

5

6

Radial evolution of particle velocity in a free jet case or in the presence of substrates at

9 x=60mm from nozzle exit

To further this investigation, velocities were measured along the radius of the plasma

jet, which corresponds to the determination of velocity vectors along the y axis. Figure 7

shows average values of magnitude of these velocity vectors at x=50.5mm and 56.5mm from

nozzle exit.

14

15

11

12

13

Free jet case

As in most cases in thermal spraying, in both cross-sections, x=50.5mm and 56.5mm,

the particle velocity radial distributions (Fig. 7) are symmetrical and show a maximum at the

center of the free plasma jet. It noted that the Gaussian evolution ordinary observed for a jet is

not very steepened in both cross-sections, with an average value of 315m·s⁻¹ at 50.5mm and of

230m·s⁻¹ at 56.5mm in a spot of 8mm in diameter.

21

22

18

19

20

Jet impinging a flat substrate

In the case of a plasma jet impinging the flat substrate, some changes are noticed compared with the kinetic behaviour in a free jet case (Fig. 7). First, at x=50.5mm, every velocity value along the y axis is about 100m·s^{-1} lower than velocity values registered in the free jet case in the same spatial position. Secondly, the concave shape of velocities distribution along the y axis flattens and becomes a rather convex curve at x=56.5mm from the nozzle exit. At 3.5mm upstream of the surface of the flat substrate, the lowest velocity value 74m·s^{-1} is then at the center of the plasma jet.

These evolutions are mainly due to a maximum of static pressure in the center of the plasma jet when meeting a wall, thus due to the effect of a stagnation zone on the plasma flow. These velocity results shows that the stagnation zone is located especially in the center of the plasma jet with a decreasing intensity on static pressure along the radial axis in just a few millimetres. The plasma flow must then be deviating in a wall jet configuration in order to explain the higher velocity values of particles registered around this center.

Jet impinging a cylindrical substrate

When comparing the radial evolution of velocities between the submicron particle flow impinging a cylindrical substrate and a flat substrate (Fig. 7), the convex shape of the velocity curve already appears at x=50.5mm and is preserved along the way. However, velocities are higher for a flow impinging the cylindrical substrate than a flow impinging the flat substrate, which can be easily explained by the drag forces. At x=50.5mm, the particle velocity radial evolution is even almost identical in magnitude to the free jet except for the velocity value at the centerline. This shows the stagnation zone is radially narrower in size and extends less farther along the plasma flow axis with this type of substrate than with the flat substrate. The additional presence of air cooling flows may also provide an air

- acceleration around the substrate to the more peripheral particles and emphasize this curvature
- effect. Consequently, the flow kinetic behaviour is also less affected radially by the presence
- of a substrate with such a curvature (25mm) than when it is impinging a flat surface.

- 5 Tilting effect of the plasma gun on particle flow kinetic behaviour near the substrate and
- 6 beads morphology

Tilting effect of the plasma gun particle velocity near the flat substrate

The angle between the normal axis of the substrate surface and the gun axial axis was set at 40° .

Figure 8 shows two instantaneous particle velocity fields between the two cases as well as the resulting average value at 3.5mm away from the substrate. This average value was obtained from the summation of all 100 velocity fields contained in a measurement window of 3x3mm² and centered at 56.5mm. Respectively, an average value of 74m·s⁻¹ was measured when the plasma jet is impinging the surface in a parallel direction of the normal axis, i.e with 0° of incidence to the normal axis, and 143m·s⁻¹ was registered when the gun was set at a 40° angle from the substrate normal axis.

Moreover, the instantaneous particle velocity fields display that clouds of submicron particles follow the plasma jet general direction. Indeed, vectors are preserving an incident angle of approximatively 0° or 40° to at least 5mm from the surface of the substrate. In the case of an incidence angle close to 0° , vectors around the centerline are starting to diverge outward and symmetrically at 5mm with a gradually decreasing magnitude. When the incidence angle is 40° to the normal axis, most of the vectors in the y- area are diverging

away from the surface of the substrate, starting 12mm upstream. In the y+ area, vectors divergence only takes place starting 5mm upstream the surface with an opening angle of about 45° to the substrate normal axis at y=0. Their divergence away from the substrate surface also keeps the set direction towards the y-. No vector was registered going against this general downward direction within the limits of the spatial dimensions of these images. The magnitude of the velocity vectors at the centerline of the plasma jet, thus diagonally on the instantaneous field (Fig. 8), also tends to decrease way less until impact compared to the impinging jet with a 0° incidence, hence the overall greater average velocity value registered in this area.

Thus, enough tilt of the substrate leads to submicron particles being less decelerated upon impact although their flow direction is more affected by it as well. The orientation of the tilt leads to a preferred general direction of the submicron particle flow with the same orientation. It also means there is a less impactful stagnation zone to the plasma flow, in terms of geometrical dimensions.

Beads morphology

Next, the influence of the angle of incidence of the general submicron particle flow was studied on beads. Figure 9 displays SEM images of the beads morphologies in relation with the orientation of the plasma jet to the normal axis of the substrate.

These morphologies correlate strongly with the registered particle flow direction before the substrate. Beads produced with a gun placed orthogonally to the substrate, thus with a incidence angle close to 0° at the centerline, display a homogeneous and rather dense morphology. Beads produced with a tilted plasma gun exhibit a morphology composed of columns with a strong directional growth oriented toward the center of the plasma jet. The

angle described by the columns orientation and the normal axis of the substrate is of about 30°

2 regardless of the position in the coating from the center of the plasma jet.

The noticed difference between this column growth angle and the incidence angle of the particles impacting has been similarly reported before on columnar microstructures produced by physical vapour-phase deposition techniques, such as PS-PVD [24] and PVD [25]. These authors seem to agree that this difference is due to atomistic particles self-shadowing while the coating is growing. A similar phenomenon of particles self-shadowing could likely be happening with these submicron particles, leading to columns with an orientation towards the center of the particle flow and with a lesser angle of growth than the incidence angle of the particle flow.

Porosity at the center of the beads was also evaluated thanks to image analysis. In both beads porosity was around 20%. Therefore it seems that neither impact velocity nor jet orientation at the centerline of the flow influence drastically the porosity level within the coating. Orientation of the plasma jet and impact velocities only influence the stacking of splats into columns or layers.

Conclusions

This study leads to a better understanding of coating growth by SPS thanks to the observation of the submicron particle velocity and direction in a plasma jet impinging on different types of substrate. Due to the very small particle sizes, a PIV set-up had to be used to apprehend this flow. Different substrates were then chosen: flat, curved or inclined.

It has been shown that:

- 1 The submicron particle flow consistently follows the plasma jet streamlines.
- 2 The substrate presence disrupts the particle flow direction and velocity up to 10mm
- 3 upstream from the substrate surface in comparison with free jets.
- 4 The positioning of air-jets is of major importance as the air flow can provoke a decrease
- of the particle flow average velocity near the substrate.
- 6 The substrate shape has an impact on the particle flow kinetic behaviour. Particles
- 7 impinged the cylindrical substrate (curvature radius of 25mm) with a higher velocity than
- 8 particles impinging the flat substrate.
- 9 When trapped in a plasma jet impinging the flat substrate with an incidence angle of 40°,
- the particle flow keeps the plasma jet incidence at the centerline and is then less deviated
- and slowed down upon impact.
- 12 The incidence angle of the submicron particle flow had a great impact on the resulting
- columns orientation of the coatings and on their deposition homogeneity.
- These experimental results also highlight the existence of a stagnation zone to the
- plasma jet flow and particle flow in the SPS process.
- However, a better characterization of the submicron particle direction and velocity
- upon impact is still required in order to attain a better understanding of the effect of the
- stagnation zone on coating growth in SPS. The next study will thus focus on better describing
- submicron particles kinetic behaviour very near a flat substrate in order to measure impacting
- velocities and their incidence angles.

22

23

Acknowledgements

- The authors would like to thank the French National Association of R&T (ANRT)
- 2 for the financial support.

1 References

- 2 [1] B. Bernard, A. Quet, L. Bianchi, V. Schick, A. Joulia, A. Malié, B. Rémy, Effect of
- 3 Suspension Plasma-Sprayed YSZ Columnar Microstructure and Bond Coat Surface
- 4 Preparation on Thermal Barrier Coating Properties, J. Therm. Spray Technol., 2017,
- 5 **26**(6), p 1025–1037
- 6 [2] E. Pfender, Fundamental studies associated with the plasma spray process, *Surf. Coat.*
- 7 *Technol.*, 1988, **34**(1), p 1–14
- 8 [3] C.W. Kang, H.W. Ng, S.C.M. Yu, Comparative Study of Plasma Spray Flow Fields and
- 9 Particle Behavior Near to Flat Inclined Substrates, *Plasma Chem. Plasma Process.*, 2006,
- **26**(2), p 149–175
- 11 [4] M. Vardelle, A. Vardelle, P. Fauchais, Spray parameters and particle behavior
- relationships during plasma spraying, *J. Therm. Spray Technol.*, 1993, **2**(1), p 79–91
- 13 [5] J.O. Berghaus, S. Bouaricha, J.G. Legoux, C. Moreau, Injection conditions and in-flight
- particle states in suspension plasma spraying of alumina and zirconia nano-ceramics,
- 15 Thermal Spray 2005: Thermal Spray Connects: Explore Its Surfacing Potential!, E.
- Lugscheider, Ed., May 2-4, 2005 (Basel, Switzerland), DVS-German Welding Society,
- 17 2005, p 2–4
- 18 [6] R. Etchart-Salas, V. Rat, J.F. Coudert, P. Fauchais, N. Caron, K. Wittman, S. Alexandre,
- 19 Influence of Plasma Instabilities in Ceramic Suspension Plasma Spraying, *J. Therm.*
- 20 *Spray Technol.*, 2007, **16**(5-6), p 857–865
- 21 [7] C. Delbos, J. Fazilleau, V. Rat, J.F. Coudert, P. Fauchais, B. Pateyron, Phenomena
- Involved in Suspension Plasma Spraying Part 2: Zirconia Particle Treatment and Coating
- 23 Formation, *Plasma Chem. Plasma Process.*, 2006, **26**(4), p 393–414
- 24 [8] H. Martin, Heat and Mass Transfer between Impinging Gas Jets and Solid Surfaces, Adv.
- 25 *Heat Transfer*, 1977, **13**, p 1–60

- 1 [9] C.G. Phillips, S.R. Kaye, The Influence of The Viscous Boundary Layer on The Critical
- 2 Stokes Number for Particle Impaction Near A Stagnation Point, *J. Aerosol Sci.*, 1999,
- **30**(6), p 709–718
- 4 [10] P. Fauchais, R. Etchart-Salas, V. Rat, J.F. Coudert, N. Caron, K. Wittmann-Ténèze,
- 5 Parameters Controlling Liquid Plasma Spraying: Solutions, Sols, or Suspensions, J.
- 6 Therm. Spray Technol., 2008, **17**(1), p 31–59
- 7 [11] M. Jadidi, M. Mousavi, S. Moghtadernejad, A. Dolatabadi, A Three-Dimensional
- 8 Analysis of the Suspension Plasma Spray Impinging on a Flat Substrate, *J. Therm. Spray*
- 9 *Technol.*, 2015, **24**(1-2), p 11–23
- 10 [12] A. Farrokhpanah, T.W. Coyle, J. Mostaghimi, Numerical Study of Suspension Plasma
- 11 Spraying, *J. Therm. Spray Technol.*, 2017, **26**(1-2), p 12–36
- 12 [13] K. Pourang, C. Moreau, A. Dolatabadi, Effect of Substrate and Its Shape on in-Flight
- Particle Characteristics in Suspension Plasma Spraying, *J. Therm. Spray Technol.*, 2016,
- **25**(1-2), p 44–54
- 15 [14] K. VanEvery, M.J.M. Krane, R.W. Trice, H. Wang, W. Porter, M. Besser, D. Sordelet, J.
- 16 Ilavsky, J. Almer, Column Formation in Suspension Plasma-Sprayed Coatings and
- 17 Resultant Thermal Properties, J. Therm. Spray Technol., 2011, 20(4), p 817–828
- 18 [15] P. Sokołowski, S. Kozerski, L. Pawłowski, A. Ambroziak, The key process parameters
- influencing formation of columnar microstructure in suspension plasma sprayed zirconia
- 20 coatings, Surf. Coat. Technol., 2014, **260**, p 97–106
- 21 [16] E. Aubignat, M.P. Planche, D. Billieres, A. Allimant, L. Girardot, Y. Bailly, G.
- Montavon, Optimization of the injection with a twin-fluid atomizer for suspension plasma
- spray process using three non-intrusive diagnostic tools, J. Visualization, 2016, 19(1), p
- 24 21–36

- 1 [17] B. Bernard, L. Bianchi, A. Malié, A. Joulia, B. Rémy, Columnar suspension plasma
- 2 sprayed coating microstructural control for thermal barrier coating application, *J. Eur.*
- 3 *Ceram. Soc.*, 2016, **36**(4), p 1081–1089
- 4 [18] Y. Zhao, Z. Yu, M.-P. Planche, A. Lasalle, A. Allimant, G. Montavon, H. Liao, Influence
- of Substrate Properties on the Formation of Suspension Plasma Sprayed Coatings, *J.*
- 6 Therm. Spray Technol., 2018, **27**(1-2), p 73–83
- 7 [19] T. Ba, C.W. Kang, H.W. Ng, Numerical Study of the Plasma Flow Field and Particle In-
- 8 flight Behavior with the Obstruction of a Curved Substrate, *J. Therm. Spray Technol.*,
- 9 2009, 18:858, doi:10.1007/s11666-009-9395-1
- 10 [20] S. Bansard, "Etude de l'ablation d'un composite –fibres de carbone, résine phénolique-
- par impact de gouttes d'alumine : Conception d'un banc d'expériences", Ph.D. Thesis,
- 12 University of Limoges, 2004
- 13 [21] H.X. Wang, X. Chen, W. Pan, Modeling Study on the Entrainment of Ambient Air into
- Subsonic Laminar and Turbulent Argon Plasma Jets, *Plasma Chem. Plasma Process.*,
- 15 2007, **27**(2), p 141–162
- 16 [22] S.L. Anderson and E.K. Longmire, Particle Motion in the Stagnation Zone of an
- 17 Impinging Air Jet, *J. Fluid Mech.*, 1995, **299**, p 333-366
- 18 [23] S.F. Hoerner, Fluid-dynamic drag: theoretical, experimental and statistical information,
- L.A. Hoerner, Ed., Hoerner Fluid Dynamics, 1992, Chap. 3
- 20 [24] P. Wang, W. He, G. Mauer, R. Mücke, R. Vaßen, Monte Carlo simulation of column
- 21 growth in plasma spray physical vapor deposition process, Surf. Coat. Technol., 2018,
- **335**, p 188–197
- 23 [25] A.G. Dirks, H.J. Leamy, Columnar microstructure in vapor-deposited thin films, *Thin*
- 24 *Solid Films*, 1977, **47**(3), p 219–233

- 1 **Fig. 1** Diagram of the PIV set-up used in this study
- 2 Fig. 2 Diagram representing the spraying distance and substrates in use
- 3 Fig. 3 Photography of a spray during PIV measurements done in presence of a rotating
- 4 stainless steel ring and cooling air-jets
- 5 **Fig. 4** Photography of two spray in front of a stainless steel ring with air-jets off or air-jets on
- 6 Fig. 5 Evolution at the centerline of the plasma flow of particle average velocity magnitudes
- 7 |v| with or without cooling air-jets or with or without the substrate presence at x=60mm from
- 8 plasma gun nozzle exit
- 9 Fig. 6 Average of particle velocity magnitudes at the plasma jet centerline when impinging
- cylindrical and flat substrates positioned at x=60mm and with the use of air-jets
- 11 Fig. 7 Radial evolution of the average of magnitudes of particle velocities at x=50.5mm or
- 12 x=56.5mm from nozzle exit, in the case of a free plasma jet and in the presence of a
- cylindrical or flat substrate situated at x=60mm
- 14 Fig. 8 Tilting effect of the plasma gun on particle velocity at 3.5mm from the flat substrate
- 15 (window of measurement represented by the dotted rectangle) and on instantaneous particle
- velocity fields. Green arrows help to illustrate velocity vector directions & magnitudes
- 17 represented by smaller red arrows. The white clouds are puff of zirconia particles impinging
- the surface
- 19 Fig. 9 SEM images of beads obtained on rotating cylinders with a 0° (a) or 40° angle of
- 20 incidence of the plasma jet (b) to the substrate normal axis. A sketch in (b) also displays the
- 21 angle of columns to the substrate normal axis

Table 1 Spraying conditions

Gas mixture Ar/He	80%/20%
Total gas flow rate	50L·min ⁻¹
Nozzle diameter D ₀	6.5mm
Electric power	23.5kW
Plasma jet mass enthalpy	22.2MJ·kg ⁻¹
Plasma jet temperature (at nozzle exit, estimated from mass enthalpy)	13400K
Plasma jet velocity v _{g0} (calculated average at nozzle exit)	1450m·s ⁻¹
Plasma jet viscosity μ_{g0} (estimated from mass enthalpy)	2.30·10 ⁻⁴ kg·m ⁻¹ ·s ⁻¹
Stand-off distance	60mm
Injector diameter	150µm
Suspension flow rate	30mL·min⁻¹
Air-jets flow rate	15m ³ ·h ⁻¹
Chuck rotation speed	100rpm